

Notice of References Cited	Application/Control No. 10/722,478	Applicant(s)/Patent Under Reexamination MOY ET AL.	
	Examiner Sanza L. McClendon	Art Unit 1711	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Free Radical Photopolymerization. Ying Cai et al. Encyclopedia of Polymer Science and Technology [online]. March 2004 [retrieved on 2005-01-30]. Retrieved from the Internet: <URL:http://www.mrw.interscience.wiley.com/epst/articles/pst490/sect3-fs.html>.
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